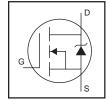
International Rectifier

IRFC2907B

HEXFET® Power MOSFET Die in Wafer Form

- 100% Tested at Probe
- Available in Tape and Reel, Chip Pack, Sawn on Film and Gel Pack**
- Ultra Low On-Resistance



75V					
$R_{DS(on)} = 2.5 m\Omega$					
(typ.)***					
6" Wafer					

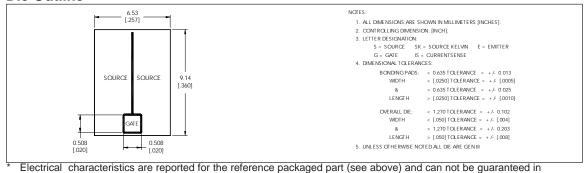
Electrical Characteristics *

Parameter	Description	Min	Тур.	Max	Test Conditions
V _{(BR)DSS}	Drain-to-Source Breakdown Voltage	75V			$V_{GS} = 0V, I_D = 250\mu A$
R _{DS(on)***}	Static Drain-to-Source On-Resistance		2.5 m Ω	4.5 m Ω	$V_{GS} = 10V, I_D = 110A$
$V_{GS(th)}$	Gate Threshold Voltage	2.0		4.0V	$V_{DS} = V_{GS}, I_{D} = 250 \mu A$
I _{DSS}	Drain-to-Source Leakage Current			20μΑ	$V_{DS} = 75V, V_{GS} = 0V, T_{J} = 25^{\circ}C$
I _{GSS}	Gate-to-Source Leakage Current			± 200nA	$V_{GS} = \pm 20V$
TJ	Operating Junction and	-55°C to 175°C Max.			
T_{STG}	Storage Temperature Range				

Mechanical Data

Nominal Back Metal Composition, Thickness:	Cr-NiV-Ag (1kA°-2kA°-5kA°)		
Nominal Front Metal Composition, Thickness:	100% AI (0.008 mm)		
Dimensions:	.257" x .360" [6.53 mm x 9.14 mm]		
Wafer Diameter:	150 mm, with 100 flat		
Wafer Thickness:	0.254 mm ± 0.025 mm		
Relevant Die Mechanical Drawing Number	01-5403		
Minimum Street Width	0.107 mm		
Reject Ink Dot Size	0.51 mm Diameter Minimum		
Recommended Storage Environment:	Store in original container, in dessicated		
	nitrogen, with no contamination		
Recommended Die Attach Conditions:	For optimum electrical results, die attach		
	temperature should not exceed 300 °C		
Reference Packaged Part	IRFP2907		

Die Outline



die sales form. Variations in customer packaging materials, dimensions and processes may affect parametric performance.

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^{**} Contact factory for these product forms.

^{***}The typical R_{DS(on)} is an estimated value for the bare die, actual results will depend on customer packaging materials and dimensions.